



Response Under 37 C.F.R. § 1.116
Expedited Procedure
Examining Group 1763
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Kuthi, et al.

Application No: 09/611,037

Filed: July 6, 2000

For: METHOD FOR MAKING A
SEMICONDUCTOR PROCESS
CHAMBER ELECTRODE

Docket No: LAM1P077A

Group Art Unit: 1763

Examiner: Alejandro, L.

Date: September 24, 2002

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CERTIFICATE OF MAILING:

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington DC 20231 on September 24, 2002.

Signed: *Nancy J. Weldy*

Nancy J. Weldy

PROPOSED AMENDMENT UNDER 37 C.F.R. § 1.116(B)

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Applicants submit this Proposed Amendment in response to the Final Office Action dated July 25, 2002. The period for response extends to October 25, 2002. Please enter the following amendments and remarks:

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IN THE CLAIMS

Please replace the filed claims with the following. All pending claims after this Proposed Amendment are listed below in clean form for the convenience of the Examiner. Marked up claims showing the proposed amendments are attached hereto. Claims amended by this Proposed Amendment are indicated as such. Please enter the following:

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